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P/1805-17



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application of

Markus Turtinen, et al.

Serial No.: 10/526,831

Filed: July 20, 2005

New York, New York

Date: April 27, 2007

Group Art Unit: 2856

Examiner: ---

For: CHARACTERISATION OF PAPER

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

SUBMISSION

Sir:

Submitted herewith is a copy of art together with a form listing the same for the convenience of the Examiner.

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents P.O. Box 1450, Alexandria, VA 22313-1450, on April 27, 2007

Robert C. Faber

Name of applicant, assignee or Registered Representative

Signature C April 27, 2007

Date of Signature

Respectfully submitted,

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RCF:mjb Enclosures

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APR 3	0 1997	Filing Date J	Filing Date July 20, 2005		Group Art Unit 2856			
U.S. PATENT DOCUMENTS (not submitted for applications filed after 6/30/03)								
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FOREIGN PATENT DOCUMENTS								
	Document Number	Date IM-YYYY	Country	Class	Sub-	Translation		
	Document Number		Country	Class	class	Yes	No	
	w-#			77-7-				

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)								
	European Search Report dated March 12, 2007							
	Jukka Iivarinen, et al. (1996) Unsupervised Segmentation of Surface Defects, IEEE, pp. 1015-4651.							
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Examiner		Date Cor	Date Considered					
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.								